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Picosecond Optoelectronic Measurement of Microstrip Dispersion

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30 September 1985

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Prepared for

SPACE DIVISION AIR FORCE SYSTEMS COMMAND Los Angeles Air Force Station P.O. Box 92960, Worldway Postal Center Los Angeles, CA 90009-2960

This report was submitted by The Aerospace Corporation, El Segundo, CA 90245, under Contract No. F04701-83-C-0084 with the Space Division, P.O. Box 92960, Worldway Postal Center, Los Angeles, CA 90009-2960. It was reviewed and approved for The Aerospace Corporation by S. Feuerstein, Director, Chemistry and Physics Laboratory. Lieutenant Carl Baner, SD/CGX, was the project officer for the Mission-Oriented Investigation and Experimentation (MOIE) program.

This report has been reviewed by the Public Affairs Office (PAS) and is releasable to the National Technical Information Service (NTIS). At NTIS, it will be available to the general public, including foreign nationals.

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SECURITY CLASSIFICATION OF THIS PAGE (When Date Entered)

REPORT DOCUMENTATION	READ INSTRUCTIONS BEFORE COMPLETING FORM			
1. REPORT NUMBER	/	3. RECIPIENT'S CATALOG NUMBER		
SD-TR-85- 72	AD-AIGI	<i>180</i>		
4. TITLE (and Subtitle)		3. TYPE OF REPORT & PERIOD COVERED		
Picosecond Optoelectronic Measu	rement	[
of Microstrip Dispersion	•			
<u>-</u> -		6. PERFORMING ORG. REPORT NUMBER		
<u> </u>		TR-0084A(5945-06)-1		
7. AUTHOR(a)		8. CONTRACT OR GRANT NUMBER(*)		
D. F. Occasion		F04701-83-C-0084		
D. E. Cooper		FU4/U1-03-C-UU04		
9. PERFORMING ORGANIZATION NAME AND ADDRES	is	10. PROGRAM ELEMENT, PROJECT, TASK AREA & WORK UNIT NUMBERS		
The Aerospace Corporation				
El Segundo, CA 90245				
11. CONTROLLING OFFICE NAME AND ADDRESS		12. REPORT DATE		
Space Division		30 September 1985		
Los Angeles Air Force Station		13. NUMBER OF PAGES		
Los Angeles, CA 90009-2960	ent from Controlling Office)	15. SECURITY CLASS. (of this report)		
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		Unclassified		
		Unclassified 15a. DECLASSIFICATION/DOWNGRADING SCHEDULE		
		SCHEOULE		
16. DISTRIBUTION STATEMENT (of this Report)				
Approved for public release; di	stribution unlimi	.ted.		
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17. DISTRIBUTION STATEMENT (of the abstract entere	d in Block 20, if different tro	on Report)		
18. SUPPLEMENTARY NOTES				
19. KEY WORDS (Continue on reverse side if necessary		, 		
Picosecond Dispers				
Optoelectronic Propaga				
Microstrip Microwa	ive			
20. ABSTRACT (Continue on reverse side if necessary s	and identify by block number)			
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The broadening and distortion of 5-psec electrical pulses propagating on microstrip lines were measured. The dispersion curve of the microstrip was				
measured with a 150-GHz bandwidth. Comparison with an approximate				
analytical dispersion formula indicates that the microstrip is much less				
dispersive than expected.				

PREFACE

The author gratefully acknowledges J. Ewan and D. Rowe for helpful discussions in interpreting the experimental results.

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I. INTRODUCTION

Very short electrical pulses can be produced by optically triggering optoelectronic switches incorporated into microstrip transmission lines. However, microstrip dispersion causes short electrical pulses to broaden and distort as they propagate. Conventional continuous-wave (cw) dispersion measurements on microstrips, have been limited to 18-GHz bandwidth. Here we report optoelectronic generation and sampling of electrical pulses with 5-psec temporal resolution and the use of these pulses to probe dispersion effects of the high-frequency microstrip propagation modes. Theoretical calculations of the dispersed pulse shapes were performed by Whinnery and coworkers; our results confirm their predictions. Fourier analysis of the dispersed pulse shapes yields the microstrip dispersion curve to about 150 GHz. The measured curve is much less dispersive than an approximate analytical dispersion curve, which may be due to the small dimensions of the microstrips used.

II. EXPERIMENTAL

Microstrip circuits incorporating optoelectronic switches were fabricated on silicon-on-sapphire wafers. The substrate was 180 μ m thick, with a 1.0- μ m epilayer of silicon. The microstrip lines were formed with 150 nm of evaporated gold; they were 180 μ m wide to provide for 50 Ω impedance. The microstrip circuit consisted of a central microstrip and four side microstrips oriented 90 deg to the central strip. A 25- μ m gap between each side strip and the central strips acted as an optoelectronic switch to generate and sample electrical pulses. The four switches were arranged to permit sampling of the pulse shape after it had propagated immediately across the microstrip and after propagation distances of 6.5 and 13 mm. The wafers were ion implanted with 400 keV Si⁺ to shorten the duration of the photoconductive response into the picosecond regime. A dose of 7 × 10¹⁴ cm⁻² was adequate for optimal temporal response; smaller doses produced greater photoconductivity with a reduction in temporal resolution.

A quasi-cw train of 3-psec optical pulses from a synchronously pumped dye laser was focused onto a biased optoelectronic switch to produce short electrical pulses on the central microstrip. As the voltage pulse propagated past one of the other optoelectronic switches it caused a transient bias, which could be detected by illumination of the switch with a second picosecond laser pulse. In this way the switches operated as sampling gates: The aperture was swept by delaying the second optical pulse. The current conducted by the sampling switch was amplified and used to drive the Y axis of an XY recorder. The X axis was driven by a voltage proportional to the position of the optical delay line, and the result was a record of the temporal profile of the electrical pulse.

III. RESULTS

Figure 1(a) shows the result of sampling the electrical pulse immediately across the microstrip from the generation site, corresponding to an optoelectronic autocorrelation function. The superimposed points are a fitted Gaussian profile. To the right of the main peak is a small shoulder, probably caused by the electromagnetic wave radiated from the biased switch reflecting off the ground plane and modulating the bias on the sampling switch. Aside from this shoulder the autocorrelation profile is quite symmetric and fairly close to a Gaussian shape. The symmetry is not expected, since the discharging of one switch and charging of the second switch should produce an asymmetric signal shape. Indeed, the minor asymmetry near the peak of the pulse does appear to be reproducible. However, if we neglect this asymmetry and assume that the 7.0-psec-wide signal results from the convolution of a Gaussian electrical pulse with a Gaussian sampling aperture, the electrical pulse width (and sampling aperture) can be inferred to be 5.0 psec. A 5.0-psec pulse has a frequency spectrum with a half-power width of 62 GHz.

Figure 1(b) shows the electrical pulse profile after 1.3 cm propagation on the microstrip. The pulse becomes distorted because low frequencies propagate on the microstrip in a nearly transverse electromagnetic (quasi-TEM) mode in which part of the electric field passes through the air above the dielectric substrate, resulting in an effective dielectric constant ε_{re} that is considerably less than the substrate dielectric constant $\varepsilon_{\tt s}$. As the frequency increases the quasi-TEM mode begins to couple to the TE, surface wave mode that propagates at the dielectric-air interface, but mostly within the dielectric. The mixed propagation mode possesses a larger effective dielectric constant, ultimately reaching the high-frequency effective dielectric constant $\epsilon_{\mbox{\tiny μ}}$. Thus, low-frequency components of the electrical pulse travel relatively fast and form the slowly rising leading edge of the pulse. The high-frequency components become concentrated in the trailing edge of the pulse and cause the observed oscillation. The data reported here represent the first observation of the reversed polarity region at the trailing edge of the pulse.

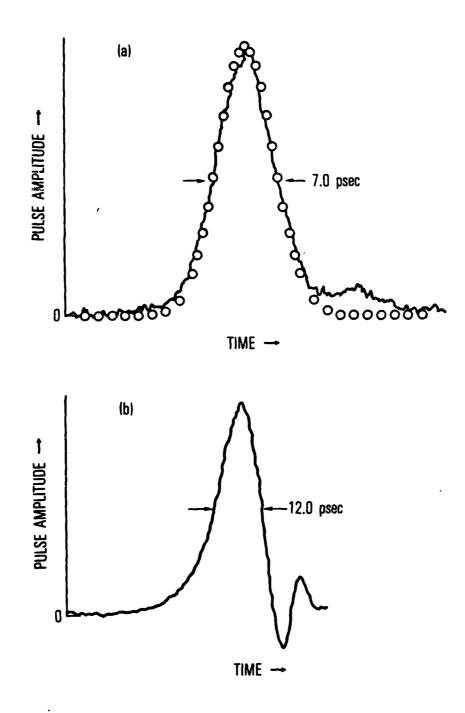


Fig. 1. Electrical pulse shape (a) with no propagation (superimposed points are a Gaussian fit); and (b) after 1.3 cm propagation.

IV. DISCUSSION

The amplitude and phase of the frequency spectrum of the pulse profiles measured at different points along the microstrip conductor can be obtained by Fourier analysis. Microstrip losses affect the amplitude of the transformed pulse spectrum, whereas microstrip dispersion affects the phase components. Here we consider the frequency spectrum of the pulse as it propagates on the microstrip line and the limitation imposed by sampling with a finite (and possibly asymmetric) aperture.

The temporal profile of the signal resulting from optoelectronic sampling of an electrical pulse propagating on the microstrip is the convolution of the pulse profile and the sampling aperture:

$$V(t;t) = P(t;t)*S(t) = P(t;0)*I(t;t)*S(t)$$
 (1)

where V(t;t) is the temporal profile of the signal after propagation over distance t, P(t;t) is the electrical pulse profile at point t, and S(t) is the sampling aperture profile. The symbol * denotes the convolution operation. The right-hand side of Eq. (1) applies the fact that the pulse profile at point t is the convolution of the initial pulse profile P(t;0) and the impulse response function I(t;t) for a section of microstrip of length t.

If we use the properties of the Fourier transforms of convolutions, ⁸ Eq. (1) can be written (using the "bar" notation to indicate a Fourier transform)

$$\overline{V(f;t)} = \overline{P(f;t)} \times \overline{S(f)} = \overline{P(f;0)} \times T(f;t) \times \overline{S(f)}$$
 (2)

This is the form that is useful for analyzing the dispersed pulse profiles. $T(f;\ell) = \overline{I(f;\ell)}$, the transfer function for transmission through a length ℓ of microstrip, completely describes the electrical properties of the microstrip (in a linear approximation).

The initial pulse P(t;0) will generally have an exponential tail due to the exponentially decaying photoconductivity response after optical excitation. The resulting asymmetry in P(t;0) is equivalent to a frequency-dependent phase angle in $\overline{P(f;0)}$. The sampling aperture will be approximately equal to the time-reversed initial pulse profile:

$$S(t) \approx P(-t;0) \tag{3}$$

If this approximation holds, then V(t;0) is an autocorrelation function and it will be completely symmetric. The symmetry of Fig. 1(a) indicates that Eq. (3) is a good approximation. Then the phase angles of $\overline{S(f)}$ will be equal and opposite those of $\overline{P(f;0)}$, and any nonzero phase components of $\overline{V(f;\ell)}$ must be due to $T(f;\ell)$ [Eq. (2)]. Thus the asymmetry in the sampling aperture exactly compensates for an identical asymmetry in the initial pulse, and the microstrip dispersion is measured directly.

Microstrip dispersion can be expressed as a variation in propagation constant $\beta=2\pi/\lambda$ with frequency. The ratio between the propagation constant on the microstrip and the propagation constant in vacuum β_0 is equal to the square root of the effective dielectric constant ϵ_{rs} :

$$\frac{\beta(f)}{\beta_0} = \varepsilon_{re}^{1/2}(f) = \frac{\lambda_0}{\lambda(f)} = \frac{c}{f\lambda(f)}$$
 (4)

where λ_0 is the wavelength in vacuum.

The phase angle (in radians) of a wave propagating along a microstrip will equal the distance propagated ℓ times the propagation constant $2\pi/\lambda$:

$$\phi(f) = \frac{2\pi \ell}{\lambda(f)} \tag{5}$$

Substituting Eq. (4) into Eq. (5), we solve for the effective dielectric constant

$$\varepsilon_{\rm re}^{1/2}(f) = \phi(f) \frac{c}{2\pi \ell} \frac{1}{f} \tag{6}$$

Equation (6) enables the dispersion function $\epsilon_{re}^{1/2}(f)$ to be calculated from the phase information in T(f;t). The low-frequency limit of ϵ_{re} is determined by

the arrival time of the pulse (112 psec), and the dispersion curve is calculated from Eq. (6) and the frequency-dependent phase angles of T(f; l).

The dispersed pulse shape of Fig. 1(b) was digitized and analyzed with a fast Fourier transform routine on a microcomputer. The $\epsilon_{re}^{1/2}$ was calculated from the transform phase components and Eq. (6), and the results are plotted in Fig. 2 (dotted curve). The data indicate a smooth frequency dependence to as high as 150 GHz, where the noise starts to grow because of the small amplitude of these frequency components. In fact the amplitude of the 150-GHz component is less than 10^{-3} that of the dc component, so the excellent frequency bandwidth of the data testifies to the good signal-to-noise properties of the picosecond optoelectronic data.

Also plotted in Fig. 2 is the dispersion curve calculated from an approximate analytical equation (solid curve). The parameters used to calculate this curve are the microstrip dimensions and the sapphire dielectric constant perpendicular to the substrate, which is 9.95 for the sapphire orientation used here. Clearly, the observed dispersion is much flatter than that expected at lower frequencies, which may indicate that the cutoff frequency for the TE_1 surface wave mode is higher than expected for these small (w=h=180 μ m) microstrip structures. We are proceeding with further investigations of this problem.

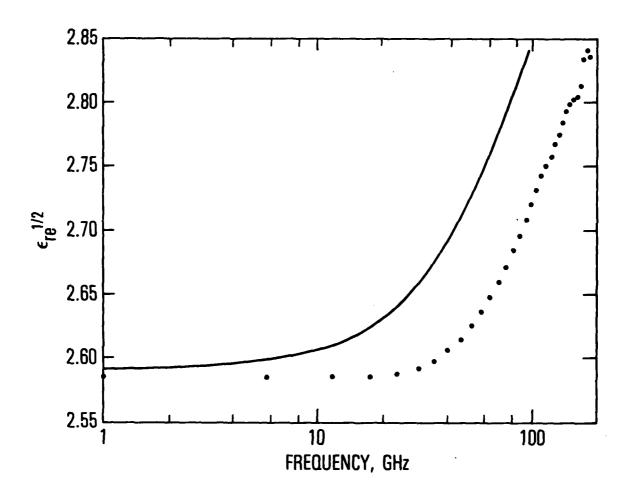


Fig. 2. Microstrip dispersion curves: solid line is calculated curve (Ref. 5); points are derived from Fourier analysis of experimental data.

V. SUMMARY

The dispersion of short electrical pulses on microstrip lines was investigated with picosecond optoelectronic techniques, the temporal resolution of which enabled the microstrip dispersion curve to be measured with a 150-GHz bandwidth. The results indicate that the dispersion of the relatively small microstrips used in this work was significantly less than expected from previous studies.

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